

<b>Notice of References Cited</b>	Application/Control No. 10/053,229	Applicant(s)/Patent Under Reexamination CHANG ET AL.	
	Examiner Annan Q. Shang	Art Unit 2617	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,673,253	09-1997	Shaffer, Shmuel	370/229
*	B	US-6,889,385	05-2005	Rakib et al.	725/119
*	C	US-6,473,902	10-2002	Noritomi, Masami	725/91
*	D	US-6,185,205	02-2001	Sharrit et al.	370/389
*	E	US-6,907,301	06-2005	Kou et al.	700/19
*	F	US-6,844,895	01-2005	Billerbeck et al.	348/211.2
*	G	US-6,678,737	01-2004	Bucher, Tim	709/231
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.